

Docket No.: 1268-093A



PATENT

2851
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Moshe FINAROV

U.S. Patent Application No. 09/626,793

Filed: July 26, 2000

Confirmation No. 8657

Group Art Unit: 2851

Examiner: D. Esplin

For: APPARATUS FOR INTEGRATED MONITORING OF WAFERS AND FOR PROCESS CONTROL IN THE SEMICONDUCTOR MANUFACTURING AND A METHOD FOR USE THEREOF

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

- ☐ No additional fee is required.
☐ Small entity status of this application has been established.
☒ Also attached: *Replacement Sheet of Drawings and Petition for Extension of Time*

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	22	20	2	x \$ 9 =	\$18.00
Independent Claims	3	3	0	x \$ 42 =	\$0
If multiple claims newly presented, add \$280.00					n/a
Fee for extension of time: 2 Month					\$205.00
TOTAL FEE DUE					\$223.00

- ☒ A credit card authorization form in the amount of \$223.00 is attached
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 07-1337, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

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